

| | | | | | | |
|-----|------|-----------------------------------------------------------------------------------------------------------------------------------------|-------------------------------------------------------------------|----|-----|------------------|
| L21 | 1 | (cvd or chemical adj vapor adj deposit\$4) near4 (copper cu) near2 low near temperature near8 (c! degree centigrade celsius celcius) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 18:14 |
| L22 | 275 | (cvd or chemical adj vapor adj deposit\$4) near4 low near temperature near8 (c! degree centigrade celsius celcius) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 18:14 |
| L23 | 31 | (cvd or chemical adj vapor adj deposit\$4) near2 low near temperature near2 (c! degree centigrade celsius celcius) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 18:17 |
| L24 | 0 | (cvd or chemical adj vapor adj deposit\$4) near2 low near temperature near2 (c! degree centigrade celsius celcius) near8 (cu or copper) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 18:17 |
| L25 | 0 | (cvd or chemical adj vapor adj deposit\$4) near2 low near temperature near2 (c! degree centigrade celsius celcius) same (cu or copper) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 18:17 |
| L26 | 0 | (pvd or physical adj vapor adj deposit\$4) near2 low near temperature near2 (c! degree centigrade celsius celcius) same (cu or copper) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 18:18 |
| L27 | 42 | (pvd or physical adj vapor adj deposit\$4) near8 (c! degree centigrade celsius celcius) near4 (cu or copper) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 18:22 |
| L28 | 55 | (electrolytic) near8 (degree centigrade celsius celcius) near4 (cu or copper) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 18:23 |
| L29 | 3330 | ((438/623) or (438/725) or (438/780) or (438/781) or (438/783)).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/01/05 18:44 |

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|---------|-----------------------------------------------------------------------------------------------------------------|---------------------------------------------------------|------------------|---------|------------------|
| L1 | 548659 | poly(phenylene) or poly near2 phenylene | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:12 |
| L2 | 4 | "20030004218".pn. "20030218253".pn. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:12 |
| L3 | 4 | 2 and (heat\$4 thermal\$4 anneal\$4 rta rtp decompos\$4 breakdown break\$4 evaporat\$6 dissociat\$4 dissolv\$4) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:15 |
| L4 | 4538753 | (heat\$4 thermal\$4 anneal\$4 rta rtp) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:15 |
| L5 | 2254497 | (decompos\$4 breakdown break\$4 evaporat\$6 dissociat\$4 dissolv\$4) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:15 |
| L6 | 879 | porogen | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:15 |
| L7 | 41 | 6 near4 5 near4 4 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:20 |
| L8 | 20 | 7 and (@ad < "20021121") | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:20 |
| L9 | 3880064 | remov\$4 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:19 |
| L10 | 66 | 6 near4 9 near4 4 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:20 |

| | | | | | | |
|-----|--------|----------------------------------------------------------------------------------------------------------------------------------------|---------------------------------------------------------|----|----|------------------|
| L11 | 42 | 10 and (@ad < "20021121") | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:29 |
| L12 | 216432 | (cvd or deposit\$4) near4 (metal copper cu aluminum al!) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:31 |
| L13 | 23 | 11 and 12 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:32 |
| L14 | 11791 | (cvd or deposit\$4) near4 (metal copper cu aluminum al!) near4 (c! degree centigrade temperature celsius celcius) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:33 |
| L15 | 0 | 11 and 14 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:33 |
| L16 | 56400 | (cvd or deposit\$4) near4 (metal copper cu aluminum al!) same (c! degree centigrade temperature celsius celcius) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:49 |
| L17 | 10 | 11 and 16 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:33 |
| L18 | 660 | (cvd or deposit\$4) near2 (copper cu) near2 (c! degree centigrade temperature celsius celcius) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 17:51 |
| L19 | 56 | (cvd or chemical adj vapor adj deposit\$4) near2 (copper cu) near2 (c! degree centigrade temperature celsius celcius) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 18:13 |
| L20 | 1 | (cvd or chemical adj vapor adj deposit\$4) near2 (copper cu) near2 low near temperature near8 (c! degree centigrade celsius celcius) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/05 18:14 |